Inventor: Hsin-Yu KUO et al. Docket No. 4425-167

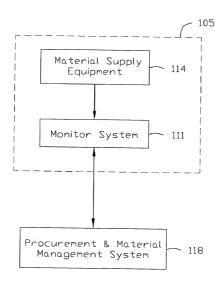
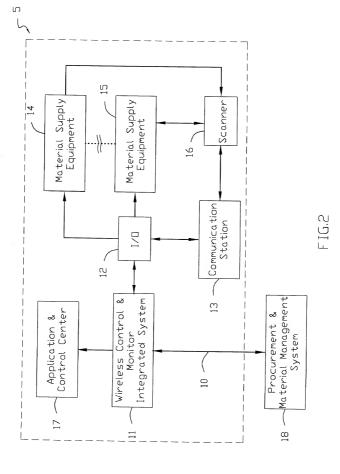


FIG.1(PRIOR ART)



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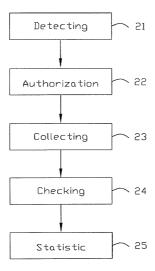
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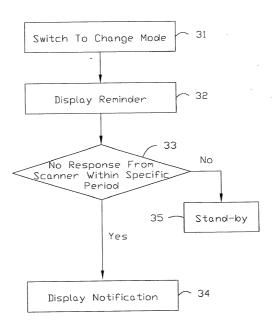


FIG.4A

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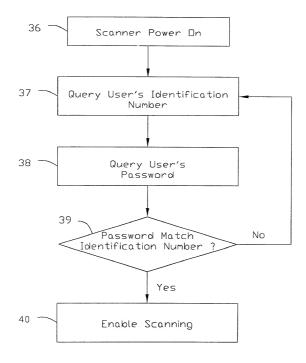
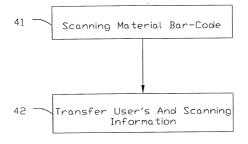
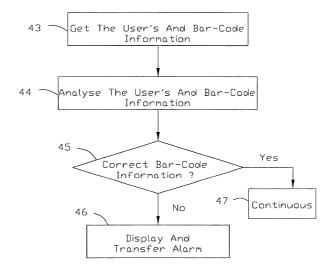


FIG.4B

'TITLE: SYSTEM AND METHOD FOR INTERLOCKING MANAGEMENT IN SEMICONDUCTOR MATERIAL , SUPPLY EQUIPMENT Inventor: Hsin-Yu KUO et al. Docket No. 4425-167



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